

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. 10/051,678
Priority Filing Date January 16, 2002
Inventor..... Li Li et al.
Assignee Micron Technology, Inc.
Priority Group Art Unit 2824
Priority Examiner Michael Lebentritt
Attorney's Docket No. MI22-2441
Title Processing Method of Forming MRAM Circuitry

PRELIMINARY AMENDMENT

To: Mail Stop Patent Application
Commissioner for Patents
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VIA EXPRESS MAIL

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Please enter the following amendments prior to examining the above-identified application.

AMENDMENTS

Amendments to the Title

Please amend the title as following:

~~Methods of Forming Integrated Circuitry, Semiconductor Processing~~

~~Methods, and Processing Method of Forming MRAM Circuitry~~